

FORM PTO 1449 (modified)

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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

Date Submitted to PTO: February 15, 2005

APPLICANT
Nobuyoshi KOSHIDA et al.FILING DATE
February 15, 2005

GROUP

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO	
	AJ	11-300274	11/999	JP			X	
	AK	62-263062	11/1987	JP				
	AL	9-505913	6/1997	JP				
	AM							
	AN							

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

	AO	H. Shinoda et al. "Thermally induced ultrasonic emission from porous silicon", Nature, Vol. 400, No. 6747, pp. 853-855, August 1999.
	AP	
	AQ	

EXAMINER /Huyen Le/

DATE CONSIDERED 03/16/2009

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /HL/